

# AMENDMENT TRANSMITTAL LETTER

Docket No.  
M4065.0319/P319

Application No.  
09/296,835

Filing Date  
April 22, 1999

Examiner  
E. Kielin

Art Unit  
2813

Applicant(s): Ronald A. Weimer, et al. TC 2800 MAIL ROOM

Invention: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

## TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	37	- 37 =		x	0.00
Independent Claims	4	- 4 =		x	0.00
Multiple Dependent Claims (check if applicable)					<input type="checkbox"/>
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					

☒ Large Entity

☐ Small Entity

☐ No additional fee is required for this amendment.

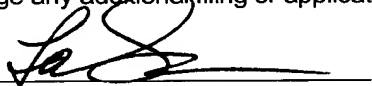
☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
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☒ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.

☒ The Commissioner is hereby authorized to charge and credit Deposit Account No. 04-1073 as described below. A duplicate copy of this sheet is enclosed.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

  
Thomas J. D'Amico  
Attorney Reg. No.: 28,371

Dated: March 13, 2002

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TC 2800 MAIL ROOM

Docket No.: M4065.0319/P319  
(PATENT)

#23/One  
3/19/02  
Harrison

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Ronald A. Weimer, et al.

Application No.: 09/296,835

Group Art Unit: 2813

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For: FABRICATION OF DRAM AND OTHER  
SEMICONDUCTOR DEVICES WITH AN  
INSULATING FILM USING A WET  
RAPID THERMAL OXIDATION PROCESS

AMENDMENT UNDER 37 CFR 1.116

Box AF

Commissioner for Patents

Washington, DC 20231

Dear Sir:

In response to the Office Action dated December 13, 2001 (Paper No. 22), finally rejecting claims 2-6, 8 and 10-12, please amend the above-identified U.S. Patent application as follows:

In the claims:

Please rewrite claim 8 as shown in the Replacement Claims:

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CIC 3/18/02